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[CITATION] Advanced Process Control: Soon to Be a Must

J Baliga - Semiconductor International, 1999

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production tools "David Jimenez"

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A Selection - ww.k.com

... development to our clients, □ states **David Jimenez**, President of WWK. ... Rate 20,000/mo Full **production** after ramp up Processing **Tools** 155 51 different tool types ...

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L Simulation - ww.k.com

... A 1- to-2 quarter faster **production** ramp rate ... their billion dollar asset portfolios," stated **David Jimenez**, President of ... Purchase analysis **tools** are rarely ...

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CTR Strategies - ww.k.com

... Use of discrete-event simulation **tools** gives the ... n Partner with **production**, especially in the ... support for our customers, □ states **David Jimenez**, President of ...

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CBW Etch, F Operations - ww.k.com

... Removal of **Tools** from Inventory ... at the process steps allowing selective **production** sam- pling ... support for our customers, □ states **David Jimenez**, President of ...

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ABC Planning - ww.k.com

... This could include the transition from 200mm to 300mm or advanced **production** at 200mm. ... The use of decision support **tools** in making these strategic decisions is ...

[View as HTML](#) - [Web Search](#)SUR

MN Hadley, WT Monacci, JM Ecklund - MD - neurosurgeon.org

... It functions as a con- duit for the **production** and approval of practice parameters ... These **tools** are to be used to apply medical effectiveness research, to assess ...

[View as HTML](#) - [Web Search](#)President's

A Addresses - aans.org

... of The American Association of Neurological Surgeons Michael LJ Apuzzo, MD, Editor Barbara Peck, Staff Editor Tony Loster, CGCM, **Production** Manager Jennifer ...

[View as HTML](#) - [Web Search](#) - [aans.org](#) - [aans.org](#)[book] Agroecology

SR Gliessman - 1997 - print.google.com

... Case Study: Conversion to Organic Apple **Production** ... the environment, but to provide useful **tools** to help ... Espinosa, Fausto In- zunza, **David Jimenez**, Silas Romero ...

[Cited by 5](#) - [Web Search](#)

[book] Introduction to Crime Analysis: Basic Resources for Criminal Justice Practice

DA Osborne, SC Wernicke - 2003 - print.google.com

... Following a logical path, the authors provide definitions, tools, practical examples, resources, and the broad over- view needed to function as a crime ana ...

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first second time average "production tools" -2

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ORGANIZATION AND ECONOMICS OF PRODUCTION

S UNITS - springerlink.com

... unit has three modes of actual **average** hourly production ... air separation units calculated by the **first**, **second**, and third ... Ta is the actual operating **time** of the ...

[Web Search](#)

Particle Concentrations Over **Production Tools** During Processing; A Comparison of Facilities

...
S Abuzeid, AT Inc, CA Milpitas - Semiconductor Manufacturing Science Symposium, 1993. ISMSS ..., 1993 - ieeexplore.ieee.org

... directly over the process tool was **first** verified by ... The **second** sample shows the airborne particle counts over a ... Pipe 7: Particle concentration vz **Time** on a ...

[Web Search](#) - ieeexplore.ieee.org

A DETECTION AND DIAGNOSIS APPROACH BY STATE ESTIMATION APPLIED TO PRODUCTION MACHINES

JM OLIVE, FB Hmida, M Egea - Decision and Control, 1995., Proceedings of the 34th IEEE ..., 1995 - ieeexplore.ieee.org

... based on two perception and processing levels [2]. The **first** one localizes as ... For a current sensor fault at the instant **time** 0 = 0.6 **second** with amplitude G ...

[Web Search](#) - ieeexplore.ieee.org

Reducing flow **time** in aircraft manufacturing

JSK Chao, SC Graves - 1992 - extenza-eps.com

... for a company's product, there is a **second** type of ... Note that for the **first** two jobs in the production ... Flow **time** 10 days Cycle **time** 2 days Tooling positions 5 ...

[Cited by 1](#) - [Web Search](#) - dspace.mit.edu - ideas.repec.org - hdl.handle.net - [all 8 versions](#) »

Integrating Digital Archives and Multimedia **Production Tools**

M HERZOG, R PERATELLO - cms.livjm.ac.uk

... another 20%, totaling to a 35% **time** advantage compared ... publisher incurs two-fold benefits: **First**, the manual ... **Second**, the publications can be delivered not only ...

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Managing the process of engineering change orders: the case of the climate control system in

...
C Terwiesch, C Loch - 1997 - insead.edu

... Prior to that, **time** performance could not be measured, and ECO management did not receive the same ... **Second**, and partly related to the **first** point, we found ...

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Analysis of the congruence between manufacturing strategy and production system in SMME

K Saefsten, M Winroth - Computers in Industry, 2002 - iprod.auc.dk

... For the **second** case another medium sized manufacturing company was ... for this was that, during the **first** analysis, it ... Systems (FMS) and Just-In-Time (JIT) were ...

[Cited by 1](#) - [View as HTML](#) - [Web Search](#) - iprod.auc.dk - portal.acm.org

Using the Web to Improve Computer-Aided Instruction in Economics

JI Daniel - Journal of Economic Education, 1999 - indiana.edu

... is a nice way of illustrating relationships between **first** and **second** derivatives
and ... professors who spend significant amounts of **time** developing utilities ...

[Cited by 11](#) - [View as HTML](#) - [Web Search](#)

Color Management: Current Practice and

A Tony - color.org

... **First**, in real production environments, the source image is ... **Second**, color space conversions may lose some precision ... At the **time** this paper, the authors have ...

Cache - Web Search

Attention! Production! Audience!—Performing Video in its **First** Decade, 1968-1980

C Hill - bavc.org

... For the **first time** in history the media are making possible mass participation in a social and socialized productive process, the practical means of which are ...

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Time code and genlock support integrated with. MX **Control**. Full model builder for designing and. creating kinematic models, marker **sets** and ...

www.vicon.com/products/documents/Vicon_iQ2_lr.pdf - [Similar pages](#)

[PDF] [Glossary of Commonly Used Vibration and Vibration **Control** Terms](#)

File Format: PDF/Adobe Acrobat - [View as HTML](#)

Vibration **Control** Terms. Absolute. A term applied to. calibration (eg of an accelerometer). based upon the primary standards of. mass, length and **time**. ...

www.newport.com/file_store/PDFs/tempPDFs/Glossary_of_Commonly_e3933.pdf - [Similar pages](#)

[PDF] [HD DaVE](#)

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color selection, with mathematical processing taking the **average**. of up to six chroma levels. Color Correction. As HD has five **times** the information than ...

www.snellwilcox.com.cn/knowledgecenter/books/books/hd_dave.pdf - [Similar pages](#)

[PDF] [Will Plunger Lift Work in My Well](#)

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offers is the lowest **average** flowing bottom hole pressure possible through stopcock flow. ... It responds to a **set** interval of **time** on the wheel to send ...

www.fergusonbeauregard.com/technicalpaper/Introduction_to_Plunger_Lift.pdf - [Similar pages](#)

[PDF] [The Difference.](#)

File Format: PDF/Adobe Acrobat - [View as HTML](#)

Schock **sets** high. standards of quality providing a reference ... over long periods of **time** and an. above-**average** service permit such a ...

www.schock-metall.de/english/schock_e.pdf - [Similar pages](#)

[PDF] [CineLook for Discreet Logic](#)

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... gets larger as the magnification decreases, but the **average** contrast (the ... This **sets** CineLook to color mode. ... Click on the **Control** 1 button to bring up the grain ...

www.digieffects.com/frames/manuals/cineLookdiscreetdocs.pdf - Supplemental Result - [Similar pages](#)

[PDF] [WebManager: A Web-Based Network Management Application Abstract](#)

File Format: PDF/Adobe Acrobat - [View as HTML](#)

... SNMP versions 1 and 2, no active **control** of the ... perform suitable actions when such alarms are **set** off ... The **average** value indicates the fraction of **time** the link ...

www.pop-pb.rnp.br/webmanager/descricao.pdf - Supplemental Result - [Similar pages](#)

[PDF] [Microsoft PowerPoint - Supplier Guide 01-05.ppt](#)

File Format: PDF/Adobe Acrobat - [View as HTML](#)

TIME (WKS). **TOTAL PRODUCTION TOOL\$**. **PRE-PRODUCTION INVESTMENT COSTS**:. **POTENTIAL** ... (Inventory Turns are a 3 month rolling **average**) ...

www.respironics.com/customer_service/supplier_information/downloads/Supplier_Guide.pdf - [Similar pages](#)

[PDF\] Use of Artificial Neural Networks in Geomechanical and Pavement ...](#)

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for each example. The training time is therefore zeroed and the weights are initialized to the. coordinates of the feature vectors in the training set. ...

gulliver.trb.org/publications/circulars/ec012.pdf - [Similar pages](#)

[PDF\] International Software Engineering Research Network Technical ...](#)

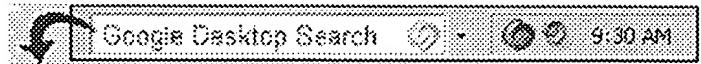
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separable activities. different Goal refinements may yield to different sets of Hypotheses, and, at the. same time, hypothesis formulation may improve the ...

search.iese.fhg.de/network/ISERN/pub/technical_reports/isern-99-17.pdf - Supplemental Result - [Similar pages](#)

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Real time dispatch gets real time results

K Appleton-Day, L Shao, AMD Inc, TX Austin - ... Conference Proceedings, 1997 IEEE International Symposium ..., 1997 - [ieeexplore.ieee.org](#)

... Since the tool **sets** and processes vary significantly throughout ... evaluate effect on performance to mix and cycle **time**. ... to 4). It currently takes an **average** of 2 ...

Cited by 1 - [Web Search](#) - [ieeexplore.ieee.org](#)

Real-Time Dispatch Gets Real-Time Results in AMD's Fab 25

K Appleton-Day, L Shao, AM Devices - [ieeexplore.ieee.org](#)

... of the back end processes share the same tool **sets**. ... set was retrieved **real-time** every **time** a dispatch ... we are extremely satisfied with an **average** response **time** ...

[Web Search](#) - [ieeexplore.ieee.org](#)

Resource Portfolio Planning Methodology for Semiconductor Wafer Manufacturing

YC Chou, RC You - The International Journal of Advanced Manufacturing ..., 2001 - [springerlink.com](#)

... can be used to predict the **average** batch size ... The relative position of the two **sets** of portfolios ... capacity checking system with cycle **time** considered", The ...

Cited by 4 - [Web Search](#) - [agsrv.ie.ntu.edu.tw](#)

Heuristics for a tool provisioning problem in a flexible manufacturing system with an automatic tool ...

HB Jun, YD Kim, HW Suh - IEEE Transactions on Robotics and Automation, 1999 - [ieeexplore.ieee.org](#)

... the same tool at the same **time** when there ... **sets** (see Table III for a description of these **sets**). ... of optimal solutions each algorithm found, **average** and standard ...

Cited by 5 - [Web Search](#) - [ieeexplore.ieee.org](#)

On-line learning delivery decision support system for highly product mixed semiconductor foundry

CY Yu, HP Huang - IEEE Transactions on Semiconductor Manufacturing, 2002 - [ieeexplore.ieee.org](#)

... **time** for those information is below 10 min in **average**. ... about 3 days and 50 000 data

sets for warming ... and PM Shabe, "Trade-off in cycle **time** management: Hot ...

[Web Search](#) - [hifive1.isye.gatech.edu](#) - [ieeexplore.ieee.org](#) - [csa.com](#)

A FINITE-CAPACITY BEAM-SEARCH-ALGORITHM FOR PRODUCTION SCHEDULING IN SEMICONDUCTOR MANUFACTURING

E Yuecesan, CH Chen, JL Snowdon, JM Charnes - [portal.acm.org](#)

... tion/**control** steps. ... The corresponding quantities are denoted by + aver D and - aver D . • **Average** cycle **time** of product P:)P (CT

[Web Search](#) - [simulation.section.informs.org](#) - [informs-cs.org](#) - [cdserv4.inria.fr](#) - [all 6 versions »](#)

Deploying Complex Decision Technologies with APL to Solve the Daily Output Planning Problem: A Tale ...

K Fordyce, GG Sullivan - APL, 1995 - [portal.acm.org](#)

... management and technicians, simulation, and running an optimization that includes **time**. ... **average**. ... A gateway to the floor **control** system allows us to ...

[Web Search](#) - [portal.acm.org](#)

Finite capacity scheduling--packed placement sequence schedule

RL Martin, C White - International Journal of Production Research, 2005 - dx.doi.org
... equal to the higher of the **average** activity duration ... bar chart (figure 10) are the
time order of ... backward infinite check_load schedule is to **control** the order ...
[Cited by 1](#) - [Web Search](#) - [taylorandfrancis.metapress.com](#) - [ingentaconnect.com](#)

Power Power The The Technology Technology ofof

A Calgary, C Calgary, C Alberta - euwelding.com

... T HE ABILITY to remotely **control** and change the welding parameter settings on the ...
its welding equipment it considered the quality and cost of weld **time** and the ...

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book Computer Generated Physical Properties

S Bumble - 1999 - print.google.com

... 118 3. 12 Computer Simulation, Modeling, and **Control** of Environmental Quality 119 ...
124 3.20 Deconvolution 124 3.2 1 Wavelets 124 3.22 Time Series 125 ...

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Parallel simulation of a large-scale aerospace system in a multicomputer environment

BE Wells, KG Ricks, JM Weir - IEEE Transactions on Aerospace and Electronic Systems, 1997 - eb.uah.edu
 Wells/Ricks/Weir – IEEE Transactions on Aerospace and Electronic Systems –
 Vol. 33, No. 2, pp. 507-523, April 1997. ... B. Earl Wells Department of ...
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[CITATION] A Survey and Analysis of Existing Constraint Combination Formalisms and Their Applications to ...

KG Ricks, DJ Jackson, BE Wells - Computers and Their Applications, 2003
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[CITATION] More Accurate Semantics Defining Constraint Combination for Software Systems Having Client-Server ...

KG Ricks, DJ Jackson, BE Wells - Computers and Their Applications, 2003
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A CRYPTANALYSIS OF THE TINY ENCRYPTION ALGORITHM

VR ANDEM, A THESIS, A TUSCALOOSA - unix.eng.ua.edu
 ... Their guidance and feedback were crucial to my work. I want to thank Dr. **Kenneth Ricks** for serving on my thesis committee, and for providing valuable feedback. ...
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Hardware/Software Co-Design of Embedded Real-Time Systems from an Undergraduate Perspective

KC Kassner, KG Ricks - ncsu.edu
 The increasing complexity of embedded systems parallels the difficulty of adequately preparing students to design them. Two topics key to the success ...
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FPGA-Based Autonomous Vehicle Competitions in a Capstone Design Course

DJ Jackson, KG Ricks - Proceedings of the 2005 IEEE International Conference on ..., 2005 - portal.acm.org
 Robotic vehicle designs and competitions often serve as the basis for undergraduate senior capstone design courses in electrical and computer ...
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The Application of Software Process Precedence Relationship Formalisms to Concurrent Hardware ...

KG Ricks, DJ Jackson, BE Wells - kricks.eng.ua.edu
 In this paper, precedence constraint combination formalisms defined in the software domain are used to define the behavior of hardware systems. ...
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An Embedded Systems Course and Course Sequence

KG Ricks, WA Stapleton - ncsu.edu
 Page 1. An Embedded Systems Course and Course Sequence Kenneth G. Ricks*
 Electrical and Computer Engineering The University of Alabama ...
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SADL: Simulation Architecture Description Language

KG Ricks, MSF Center, JM Weir, MSF Center, BE ... - kricks.eng.ua.edu

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[CITATION] An improved bus-based multiprocessor architecture: a thesis

KG Ricks - 1997 - University of Alabama in Huntsville

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 Dance, D.; Jarvis, R.;
 Semiconductor Manufacturing, IEEE Transactions on
 Volume 5, Issue 1, Feb. 1992 Page(s):41 - 46
 Digital Object Identifier 10.1109/66.121975
[AbstractPlus](#) | Full Text: [PDF\(456 KB\)](#) IEEE JNL
- ☐ **2. Modeling the cost of ownership of assembly and inspection**
 Dance, D.L.; DiFloria, T.; Jimenez, D.W.;
 Components, Packaging, and Manufacturing Technology, Part C, IEEE Transa
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 Volume 19, Issue 1, Jan. 1996 Page(s):57 - 60
 Digital Object Identifier 10.1109/3476.484205
[AbstractPlus](#) | [References](#) | Full Text: [PDF\(428 KB\)](#) IEEE JNL
- ☐ **3. Yield enhancement challenges for 90 nm and beyond**
 Goel, H.; Dance, D.;
 Advanced Semiconductor Manufacturing Conference and Workshop, 2003 IEE
 31 March-1 April 2003 Page(s):262 - 265
[AbstractPlus](#) | Full Text: [PDF\(340 KB\)](#) IEEE CNF
- ☐ **4. Demonstration of correlations between physical and clinical image qualit
 chest and lumbar spine radiography**
 Sandborg, M.; Tingberg, A.; Sund, P.; McVey, G.; Dance, D.; Alm Carlsson, G.
 Engineering in Medicine and Biology Society, 2000. Proceedings of the 22nd A
 International Conference of the IEEE
 Volume 4, 23-28 July 2000 Page(s):3078 - 3081 vol.4
 Digital Object Identifier 10.1109/IEMBS.2000.901532
[AbstractPlus](#) | Full Text: [PDF\(356 KB\)](#) IEEE CNF
- ☐ **5. Design for environment tools for management decision making: a selecte**
 Lashbrook, W.; O'Hara, P.; Dance, D.; Veltri, A.;
 Electronics and the Environment, 1997. ISEE-1997., Proceedings of the 1997 I
 Symposium on
 5-7 May 1997 Page(s):99 - 104
 Digital Object Identifier 10.1109/ISEE.1997.605278
[AbstractPlus](#) | Full Text: [PDF\(460 KB\)](#) IEEE CNF

- ☐ **6. 0.25 μ m integrated circuit yield model design and validation**
Lakhani, F.; Dance, D.; Williams, R.;
Semiconductor Manufacturing Conference Proceedings, 1997 IEEE International
6-8 Oct. 1997 Page(s):E21 - E24
Digital Object Identifier 10.1109/ISSM.1997.664557
[AbstractPlus](#) | Full Text: [PDF](#)(432 KB) **IEEE CNF**

- ☐ **7. Applications of cost of ownership to environment, safety and health**
Dance, D.; Veltri, A.; Lashbrook, W.;
Electronics Manufacturing Technology Symposium, 1996., Nineteenth IEEE/CI
14-16 Oct. 1996 Page(s):237 - 241
Digital Object Identifier 10.1109/EMT.1996.559737
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- ☐ **8. Modeling the cost of ownership of assembly and inspection**
Dance, D.L.; DiFloria, T.; Jimenez, D.W.;
Electronics Manufacturing Technology Symposium, 1995. 'Manufacturing Tech
Present and Future', Seventeenth IEEE/CPMT International
2-4 Oct. 1995 Page(s):51 - 54
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[AbstractPlus](#) | Full Text: [PDF](#)(408 KB) **IEEE CNF**

- ☐ **9. Using yield models to accelerate learning curve progress**
Dance, D.; Jarvis, R.;
Semiconductor Manufacturing Science Symposium, 1990. ISMSS 1990., IEEE
International
21-23 May 1990 Page(s):63 - 67
Digital Object Identifier 10.1109/ISMSS.1990.66108
[AbstractPlus](#) | Full Text: [PDF](#)(504 KB) **IEEE CNF**

- ☐ **10. Estimating semiconductor yield from equipment particle measurements**
Dance, D.; Gildersleeve, K.;
Semiconductor Manufacturing Science Symposium, 1992. ISMSS 1992., IEEE
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15-16 June 1992 Page(s):18 - 23
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- ☐ **11. Application of yield models for semiconductor yield improvement**
Dance, D.L.; Jarvis, R.;
Defect and Fault Tolerance in VLSI Systems, 1992. Proceedings., 1992 IEEE
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- ☐ **12. Modeling test cost of ownership**
Dance, D. L.;
Economics of Design, Test, and Manufacturing, 1994. Proceedings., Third International
Conference on the
16-17 May 1994 Page(s):13
Digital Object Identifier 10.1109/ICEDTM.1994.496087
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- ☐ 3. **Yield enhancement challenges for 90 nm and beyond**
Goel, H.; Dance, D.;
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31 March-1 April 2003 Page(s):262 - 265
[AbstractPlus](#) | Full Text: [PDF](#)(340 KB) IEEE CNF
- ☐ 4. **Demonstration of correlations between physical and clinical image qual
chest and lumbar spine radiography**
Sandborg, M.; Tingberg, A.; Sund, P.; McVey, G.; Dance, D.; Alm Carlsson, G.
Engineering in Medicine and Biology Society, 2000. Proceedings of the 22nd A
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Volume 4, 23-28 July 2000 Page(s):3078 - 3081 vol.4
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Lashbrook, W.; O'Hara, P.; Dance, D.; Veltri, A.;
Electronics and the Environment, 1997. ISEE-1997., Proceedings of the 1997 I
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Digital Object Identifier 10.1109/ISEE.1997.605278
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- ☐ **6. 0.25 μ m integrated circuit yield model design and validation**
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